

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Hitoshi ASADA et al.**

Serial Number: **Not Yet Assigned**

Filed: **September 17, 2003**

Customer No.: 23850

For: **SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

September 17, 2003

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge
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Respectfully submitted,
ARMSTRONG, WESTERMAN & HATTORI, LLP



John P. Kong
Reg. No. 40,054

Atty. Docket No.: 031168
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
Tel: (202) 659-2930
Fax: (202) 887-0357
JKP/yap
Enclosures: PTO-1449; References (4)

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| | Applicant(s): Hitoshi ASADA | |
| | Filing Date: September 17, 2003 | Group Art Unit: |

U.S. PATENT DOCUMENTS

| Examiner Initial | Document No. | Name | Date | Class | Subclass | Filing Date (If appropriate) |
|------------------|--------------|------|------|-------|----------|------------------------------|
| | AA | | | | | |
| | AB | | | | | |
| | AC | | | | | |
| | AD | | | | | |

FOREIGN PATENT DOCUMENTS

| | Document No. | Date | Country | Translation (Yes or No) |
|--|--------------|-----------|----------|-------------------------|
| | AE | 6-112219 | 04/22/94 | Japan Abstract. |
| | AF | 9-260590 | 10/03/97 | Japan Abstract. |
| | AG | 11-126900 | 05/11/99 | Japan Abstract. |
| | AH | 11-195789 | 07/21/99 | Japan Abstract. |
| | AI | | | |

OTHER DOCUMENTS

| | | |
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| | AJ | |
| | AK | |
| Examiner | | Date Considered |